



Image AF/2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	§	
Tyler A. Lowrey	§	Art Unit: 2814
	§	
Serial No.: 09/944,478	§	
	§	Examiner: Tuan N. Quach
Filed: August 31, 2001	§	
	§	
For: Elevated Pore Phase- Change Memory	§	Docket: ITO.0506US P12499
	§	

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed February 12, 2004, reconsideration is requested in view of the following remarks.

Date of Deposit: March 2, 2004
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.
Cynthia L. Hayden
Cynthia L. Hayden